



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Frank Y. et al.
Serial No.: 10/789,319
Filed: February 27, 2004
Confirmation No.: 9202
Art Unit: 1712
Examiner: Marc S. Zimmer
Title: COMPOSITION FOR AN ETCHING MASK COMPRISING A SILICON-CONTAINING MATERIAL

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AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action ("*Office Action*") having a mailing date of December 6, 2005, with a three-month shortened statutory period for response set to expire on March 6, 2005, please amend the above-identified Application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

CERTIFICATION UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on 3-6, 2006.

Signature

Toni Stanley

(Printed name of person certifying)